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| INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary) | Attorney Docket No.: 0505-1046 Application No.: NEW NATIONAL PHASE |
| Applicant: Christophe ARNAUD | |
| Filing Date: April 13, 2005 | Group Art Unit: |

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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| /D.S.M./ | PATENT ABSTRACTS OF JAPAN vol 0145, no. 13 (C-0777), 9 November 1990 (1990-11-09) & JP 02 214537 A (FUJI DEBUISON KAGAKU KK), 27 August 1990 (1990-09-27) cited in the application abstract |
| /D.S.M./ | PATENT ABSTRACTS OF JAPAN vol. 1996, no. 01, 31 January 1996 (1996-01-31) & JP 07 232045 A (REIKA KOGYO KK), 5 September 1995 (1995-09-05) abstact |
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EXAMINER:

/Daniel S. Metzmaier/

DATE CONSIDERED

10/01/2008

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

* English language abstract provided for the Examiner's convenience

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